



Attorney Docket No. 63254-0151-US

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of) Confirmation No. 4499
Inventor(s): Li Yao *et al.*)
Appn. No.: 10/689,043) Group Art Unit: 1792
Filed: October 21, 2003) Examiner: ALANKO, A. K.
For: ABRASIVE-FREE CHEMICAL MECHANICAL POLISHING)
COMPOSITION AND POLISHING PROCESS CONTAINING SAME)

RESPONSE UNDER 37 C.F.R. §1.111

U.S. Patent and Trademark Office
Randolph Building
401 Dulany Street
Alexandria, Virginia 22314
MAIL STOP – AMENDMENT

Sir:

In response to the non-Final Office Action mailed on November 29, 2007, the time for responding to which has been extended by the concurrent filing of a two (2) month extension of time, please amend the above application as follows:

Amendment to the claims begins on page 2 of this paper; and

Remarks begin on page 7 of this paper.